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## **SDI Review Form 1.6**

Journal Name:	Asian Journal of Chemical Sciences
Manuscript Number:	Ms_AJOCS_34313
Title of the Manuscript:	Effect of Thiourea Concentration on Structural, Optical and Electrical Properties of Cu2ZnSnS¬4 Thin Films Prepared by Spray Pyrolysis Setup
Type of the Article	Original Research Article

## **General guideline for Peer Review process:**

This journal's peer review policy states that <u>NO</u> manuscript should be rejected only on the basis of '<u>lack of Novelty'</u>, provided the manuscript is scientifically robust and technically sound.

To know the complete guideline for Peer Review process, reviewers are requested to visit this link:

(http://www.sciencedomain.org/page.php?id=sdi-general-editorial-policy#Peer-Review-Guideline)

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# **PART 1:** Review Comments

	Reviewer's comment	Author's comment (if agreed with reviewer, correct the manuscript and highlight that part in the manuscript. It is mandatory that authors should write his/her feedback here)
Compulsory REVISION comments	The authors presented the synthesis of CZTS and the effect of thiourea on grain size, band gap and sheet resistance. This article has been well organized and the description is clear and the result is reasonable as well. Only one thing wanted to remind is that the XRD peak positions indicated on lines 66, which are 28.5352•, 47.4897•, and 56.3556•. Please check the resolution of the XRD system for the 2θ degree up to the fourth digital after the digital point.	
Minor REVISION comments		
Optional/General comments		

# **Reviewer Details:**

Name:	Der Yuh Lin
Department, University & Country	Department of Electronics Engineering, National Changhua University of Education, Taiwan

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